



ELECTRONIC COPY

LG790604596
Report verification at igi.org



April 11, 2026
IGI Report Number **LG790604596**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **MARQUISE BRILLIANT**
Measurements **11.08 X 5.78 X 3.76 MM**

GRADING RESULTS

Carat Weight **1.40 CARAT**
Color Grade **D**
Clarity Grade **VS 1**

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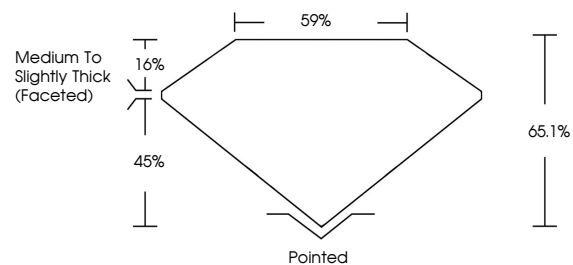
Carat Weight **1.40 CARAT**
Color Grade **D**
Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG790604596**

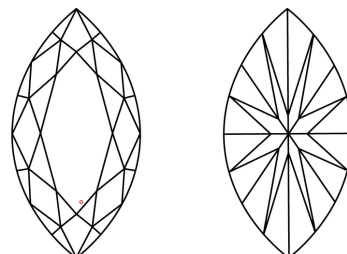
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

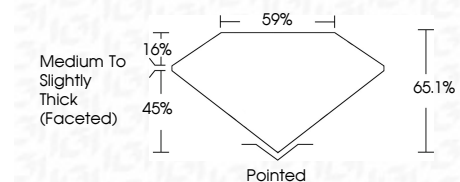
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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MARQUISE BRILLIANT
11.08 X 5.78 X 3.76 MM
1.40 CARAT
Color Grade **D**
Clarity Grade **VS 1**
Depth **65.1%**
Table **65%**
Girdle **Medium to Slightly Thick (Faceted)**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG790604596**
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